

 <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>	Docket Number (Optional) NEC WNZ-2665	Application Number 10/822,374
	Applicant(s) OHKUBO et al.	
	Filing Date April 12, 2004	Group Art Unit 2651

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,449,110	9.10.02	DeGROAT et al.	360	46	
		6,198,587	3.6.01	HAYASHI	360	65	

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/0154434	10.24.02	SATOH et al.	360	65	
		2002/0012185	1.31.02	SAWAGUCHI et al.	360	46	

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	WO 00/22620	4.20.00	PCT	G11B	20/10		
	1 160 785	12.5.01	EPO	G11B	20/10		
	09-259543	3.10.97	JAPAN (w/abstract)	G11B	20/14		

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		"A New Method to Evaluate Quality for Systems to which PRML is Applied", Nagai et al., Optical Memory and Optical Data Storage Topical Meeting, 2002, pgs. 365-367
		"Optimization of Write Strategy in a PRML System for High Density Recording", Ohkubo et al., Optical Memory and Optical Data Storage Topical Meeting, 2002, pgs. 425-427

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.